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Exr. Amendbrent	Application No.	Applicant(s)		
Notice of Allowability	10/698,563	HUIBERS ET AL.		
Notice of Allowability	Examiner	Art Unit		
	Jack Dinh	2873	<u> </u>	
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED ir or other appropriate commu GHTS. This application is s	n this application. If not includunication will be mailed in due	ed course. THIS	
1. This communication is responsive to <u>12/02/05</u> .				
2. The allowed claim(s) is/are <u>1-4 and 6-22</u> .				
3. ☐ Acknowledgment is made of a claim for foreign priority un a) ☐ All b) ☐ Some* c) ☐ None of the:		or (f).		
 Certified copies of the priority documents have 				
Certified copies of the priority documents have	• •			
Copies of the certified copies of the priority do	cuments have been received	d in this national stage applica	ation from the	
International Bureau (PCT Rule 17.2(a)).				
* Certified copies not received:	•			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the re	quirements	
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give			NOTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.			
(a) ☐ including changes required by the Notice of Draftspers	on's Patent Drawing Review	v (PTO-948) attached		
1) Thereto or 2) to Paper No./Mail Date				
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or	in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	.84(c)) should be written on the header according to 37 CF	ne drawings in the front (not the R. 1.121(d).	e back) of	
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I			Note the	
Attachment(s)	_			
1. Notice of References Cited (PTO-892)		formal Patent Application (PT	O-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		ummary (PTO-413), (Mail Date 0206		
 Information Disclosure Statements (PTO-1449 or PTO/SB/08) Paper No./Mail Date		Paper No./Mail Date <u>0206</u> . 7. ⊠ Examiner's <u>Amendment</u> /Comment		
	8. 🛛 Examiner's	8. 🛛 Examiner's Statement of Reasons for Allowance		
- -	9. 🗌 Other	<u>.</u> .		
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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Gregory R. Muir on 02/14/06. The application has been amended as follows:

In the claims:

Claim 1. (currently amended) A spatial light modulator comprising:

an array of micromirrors, each micromirror comprising a mirror plate having four predominant sides and being held on a substrate by a plurality of posts, wherein the four predominant sides define two diagonals, and wherein a line between any two of the plurality of posts is not coincident with either of the two diagonals; wherein the mirror plate is attached to a hinge that is supported by a post of the plurality of posts on the substrate; and wherein the mirror plate and hinge are separated by a gap in a direction perpendicular to the mirror plate when the mirror plate is parallel to the substrate, wherein the substrate has four predominant sides that form a rectangular shape; and wherein each side of the mirror plate is at an angle of from 5° degrees to 25° degrees to the two sides of the rectangular substrate.

Claim 5. (cancelled).

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Claims 63-64. (cancelled).

Claims 66-74. (cancelled).

REASONS FOR ALLOWANCE

- 2. Claims 1-22 are allowed. The following is a statement of the examiner's reasons for allowance. The present application relates generally to micromirror array devices. Regarding claim 1, the prior art fails to disclose that wherein the substrate has four predominant sides that form a rectangular shape; and wherein each side of the mirror plate is at an angle of from 5° degrees to 25° degrees to the two sides of the rectangular substrate. The claimed invention is therefore considered to be in condition for allowance as being novel and non-obvious over prior art.
- 3. The prior art taken either singly or in combination fails to anticipate or fairly suggest the limitations of the independent claims, in such a manner that a rejection under 35 USC 102 or 103 would be improper. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Other Information/Remarks

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4. The prior art made of record and not relied upon is considered pertinent to applicant's

disclosure. Huibers (US Patent Publication 2002/0122239), Mushika (US Patent Publication

2005/0152019), and KO et al (US Patent Publication 2002/0001122) discloses similar spatial

light modulators.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Jack Dinh whose telephone number is 571-272-2327. The

examiner can normally be reached on M-F (9:30 AM - 6:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Ricky L. Mack can be reached on 571-272-2333. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jack Dinh 2/16/06

RICKY MACK

SUPERVISORY PATENT EXAMINER